



Response Under 37 C.F.R. § 1.116
Expedited Procedure
Examining Group 2855

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) Attorney Docket No: LAM2P438
Gotkis et al.)
Application No: 10/671,978) Examiner: DAVIS, O.
Filed: September 26, 2003) Group Art Unit: 2855
For: METHOD AND APPARATUS FOR WAFER)
MECHANICAL STRESS MONITORING AND WAFER)
THERMAL STRESS MONITORING) Date: January 13, 2006

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on January 13, 2006.

Signed:


Michael L. Gencarella

Commissioner for Patents
Mail Stop AF
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	13 -	20	00	X25 = \$	OR	X50 = \$
INDEP CLAIMS	03 -	03	00	X100 = \$	OR	X200 = \$
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180		X360 \$
			TOTAL	\$ _____		\$ _____



Applicant(s) hereby petition for a one-month extension of time to respond to the outstanding Office Action. Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No.).



Enclosed is Check No. 15634 in the amount of \$120.00 to cover the additional extension of time fees. If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P438). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP


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Customer Number 25920



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Filed: September 26, 2003)	Date: January 13, 2006
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For: METHOD AND APPARATUS FOR WAFER)	
MECHANICAL STRESS MONITORING AND)	
<u>WAFER THERMAL STRESS MONITORING</u>)	

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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450, on January 13, 2006.

Signed:

Michael L. Gencarella

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir:

Applicants submit this amendment in response to the Office action dated September 13, 2005. A one month extension of time is hereby petitioned for to extend the time for response to January 13, 2006. Please enter the following remarks in the above identified application:

The claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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